00862.022476.



#### **PATENT APPLICATION**

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
	Examiner: R. Fuller
Yoshikazu MIYAJIMA et al.	)
	: Group Art Unit: 2851
Application No.: 10/022,506	)
,	: Confirmation No.: 2840
Filed: December 20, 2001	).
	: Allowed: October 27, 200
For: EXPOSURE APPARATUS, DEVICE	)
MANUFACTURING METHOD,	. January 27, 2004
SEMICONDUCTOR MANUFACTURING	)
FACTORY, AND EXPOSURE APPARATUS	:
MAINTENANCE METHOD	)
	,

#### Mail Stop RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Preliminary Amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below:

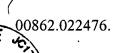
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	47	MINUS	60	= 0	x \$9 \$18	\$0.00
INDEP. CLAIMS	16	MINUS	18	= 0	x \$43 \$86	\$0.00
Fee for Multiple Dependent claims \$145/\$290						\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00	

	°Verified Statement claiming small entity status is enclosed, if not filed previously.			
	A check in the amount of \$ is enclosed.			
	Charge \$ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.			
X	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.			
	A check in the amount of \$ to cover the fee for a two month extension is enclosed.			
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.			
X	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.			
	Respectfully submitted,			
	Attorney for Applicants Steven E. Warner Registration No. 33,326			

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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# **Mail Stop RCE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

### **PRELIMINARY AMENDMENT**

Sir:

Prior to further examination on the merits, please amend the above-identified application as follows: